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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Quevedo-Lopez et al. Art Unit: 2822  
Serial No.: 10/726,987 Examiner: Thomas, T.  
Filing Date: 12/03/2003 Docket No.: TI-36376  
Customer No.: 23494 Conf. No.: 5051  
Title: TOP SURFACE ROUGHNESS REDUCTION OF HIGH-k DIELECTRIC  
MATERIALS USING PLASMA BASED PROCESSES

AMENDMENT UNDER 37 CFR 1.312

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being  
transmitted by facsimile to the U.S. Patent and  
Trademark Office at 571-273-8300 on 12/15/2005.

*Marianna Smith*  
Marianna Smith

Dear Sir:

The following amendments and remarks are offered in response to the  
Examiner's Amendment dated 10/2/2005.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification.**

**Amendments to the Claims** are reflected in the listing of claims that begin on  
page 2 of this paper.

There are no **Amendments to the Drawings.**

The **Remarks** begin on page 5.